

#70

Docket No.: M4065.0018/P018-A  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Rodney C. Langley, et al.

Application No.: 09/507,465

Group Art Unit: 1765

Filed: February 22, 2000

Examiner: M. Anderson

For: METHOD AND APPARATUS FOR  
PLASMA ETCHING A WAFER

SUMMARY OF TELEPHONIC INTERVIEW

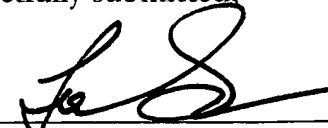
Commissioner for Patents  
Washington, DC 20231

Dear Sir:

In response to the Advisory Action mailed November 29, 2001, a telephonic inquiry was made to the Examiner by Applicants' representative on December 4, 2001 (in view of the fact that the application had not been finally rejected). On December 6, the Examiner responded that a new Office Action would issue and that the Advisory Action would be withdrawn.

Dated: December 11, 2001

Respectfully submitted,

By 

Thomas J. D'Amico

Registration No.: 28,371

John C. Luce

Registration No.: 34,378

DICKSTEIN SHAPIRO MORIN &  
OSHINSKY LLP

2101 L Street NW

Washington, DC 20037-1526

(202) 828-2232

Attorneys for Applicant

RECEIVED  
DEC 12 2001  
TECHNOLOGY CENTER 1700